

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application		OFGS File No. P/29-1642			
		Applicant Munehiro ITO					
		Filing Date		Group Art Unit			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<i>JPL</i>	7-78495	1995	Japan				X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
		English translation of Abstract for Japanese Patent					
		Laid Open Application No. Hei 7 (1995)-78495					
Examiner <i>John P. Chung</i>		Date Considered <i>2/21/06</i>					
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